



EV550720335

Inventor:

Brian E. Cron

Title:

Methods for Conditioning Surfaces of Polishing Pads After
Chemical-Mechanical Polishing

Assignee: Micron Technology, Inc.

Serial No.: 10/705,371

Filed: November 10, 2003 [RCE Filed Herewith]

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date:

9/26/05

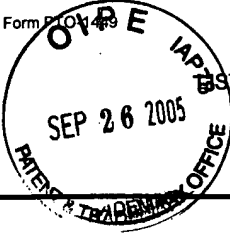
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David G. Latwesen, Ph.D.
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Form PTO-449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2430		SERIAL NO. 10/705,371	
<div style="display: flex; align-items: center; justify-content: center;"> <div style="border: 2px solid black; border-radius: 50%; padding: 10px; text-align: center; margin-right: 10px;"> OFFICE SEP 26 2005 PATENT & TRADEMARK OFFICE </div> <div> LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) </div> </div>					APPLICANT Brian E. Cron			
					FILING DATE Nov. 10, 2003 [RCE filed herewith]			GROUP 3723
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA	6,740,247 B1	05/04	Han et al.				
	AB	6,776,691 B2	08/04	Nishimura et al.				
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER		DATE CONSIDERED						
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		BEST OF ART CITED BY APPLICANT (Use several sheets if necessary)						
		APPLICANT Brian E. Cron					FILING DATE Nov. 10, 2003 [RCE filed herewith]	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	2003/0217762 A1	11/03	Kobayashi et al.				
	AB							
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